

Notice of References Cited

Application/Control No.

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Applicant(s)/Patent Under
Reexamination
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Examiner

JESSICA ROBERTS

Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,014,466 A	01-2000	Xia et al.	382/243
*	B	US-6,055,330 A	04-2000	Eleftheriadis et al.	382/154
*	C	US-6,466,624 B1	10-2002	Fogg, Chad Edward	375/240.27
*	D	US-2002/0141503 A1	10-2002	Kobayashi et al.	375/240.27
*	E	US-6,587,508 B1	07-2003	Hanamura et al.	375/240.24
*	F	US-2003/0215011 A1	11-2003	Wang et al.	375/240.03
*	G	US-6,825,886 B2	11-2004	Kobayashi et al.	348/405.1
*	H	US-2005/0053298 A1	03-2005	Mukerjee et al.	382/236
*	I	US-2005/0111547 A1	05-2005	Holcomb et al.	375/240.03
*	J	US-7,266,148 B2	09-2007	Kim, Eung Tae	375/240.03
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
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	X					

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